Jiahong

List of Publications by Year in descending order

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1040056 1058476 21 187 9 14 citations h-index g-index papers 21 21 21 86 all docs docs citations times ranked citing authors

#	Article	IF	CITATIONS
1	A Novel Bias Angle Control System for \${m LiNbO}_{3}\$ Photonic Sensor Using Wavelength Tuning. IEEE Photonics Technology Letters, 2013, 25, 1993-1995.	2.5	25
2	Design and Application of Integrated Optics Sensor for Measurement of Intense Pulsed Electric Field. Journal of Lightwave Technology, 2019, 37, 1440-1448.	4.6	23
3	3D Integrated Optical E-Field Sensor for Lightning Electromagnetic Impulse Measurement. IEEE Photonics Technology Letters, 2014, 26, 2353-2356.	2.5	19
4	Integrated Photonic Electric Field Sensor Operating More Than 26 GHz. IEEE Microwave and Wireless Components Letters, 2020, 30, 1009-1012.	3.2	17
5	Integrated Optical \$E\$-Field Sensor for Intense Nanosecond Electromagnetic Pulse Measurement. IEEE Photonics Technology Letters, 2014, 26, 275-277.	2.5	15
6	Optical Waveguide Electric Field Sensor Based on Dual Parallel Mach-Zehnder Interferometer. IEEE Sensors Journal, 2021, 21, 20099-20106.	4.7	15
7	Design and Analysis of Broadband LiNbO3 Optical Waveguide Electric Field Sensor with Tapered Antenna. Sensors, 2021, 21, 3672.	3.8	14
8	Nonâ€invasive measurement of intensive powerâ€frequency electric field using a LiNbO ₃ â€integrated optical waveguide sensor. IET Science, Measurement and Technology, 2021, 15, 101-108.	1.6	14
9	Study of an integrated optical waveguide sensor with a tapered antenna for measurement of intense pulsed electric field. Optik, 2020, 218, 164837.	2.9	10
10	Integrated optical waveguide sensor for lighting impulse electric field measurement. Photonic Sensors, 2014, 4, 215-219.	5.0	5
11	Broad-Band Integrated Optical Electric Field Sensor Using Reflection Mach-Zehnder Waveguide Modulator. Fiber and Integrated Optics, 2017, 36, 157-164.	2.5	5
12	Instantaneous microwave frequency measurement using an asymmetric integrated optical waveguide Mach-Zenhder interferometer (AMZI). Optik, 2018, 169, 203-207.	2.9	5
13	Measurements of Excavation Damaged Zone by Using Fiber Bragg Grating Stress Sensors. Sensors, 2021, 21, 5008.	3.8	5
14	Nanosecond transient electric field measurement system using an integrated electro-optic sensor. Optical Engineering, 2014, 53, 117101.	1.0	3
15	Temperature effect on the thermal properties of insulation paper. Electrical Engineering, 2021, 103, 1083-1091.	2.0	3
16	A Single Chip LiNbO \hat{a} , f Photonic 2D Electric Field Sensor Using Two Perpendicular Electrodes. IEEE Photonics Technology Letters, 2020, 32, 1501-1504.	2.5	3
17	An isotropic intense electromagnetic impulse (EMP) sensor using integrated electro-optic (EO) probe. Optik, 2017, 147, 385-390.	2.9	2
18	A LiNbO3 Integrated Optics Sensor for Measurement of Pulsed Current. Crystals, 2022, 12, 265.	2.2	2

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#	Article	IF	CITATIONS
19	A three-axis optical electric field sensor for high-altitude nuclear electromagnetic pulse (HNEMP) measurement. , 2015, , .		1
20	An Electro-Optic Sensor for Measurement of Intensive DC Electric Field. IEEE Photonics Journal, 2022, 14, 1-7.	2.0	1
21	Wavelength Tuning for LiNbO ₃ Photonic Sensor to Have Linear Operation Point. Microwave and Optical Technology Letters, 2013, 55, 2326-2329.	1.4	0